FORM PTO-1449					ATTY. DOCKET NO.		APPLICATION NO.	CONFIRMATION	NO.	
LIST OF PATENTS AND PUBLICATIONS FOR					10002305-4	•		· · · · · · · · · · · · · · · · · · ·		
	APPLI	CANT'S INFORMAT	ION DISCLOSURE		APPLICANT Dani I R. Marshall					
STATEMENT					FLING DATE GROUP					
(Use several sheets if necessary)					Herewith Unkn.					
REFER	RENCE	DESIGNATION	U.S.	PATEN	T DOCUMENTS					
EXAMINET DOCUMENT PUBLICATION NUMBER DATE				NAME		Pages, Columns, Lines Where Relevant Passages or Figures Appear				
M) 1A	3,971,362	07/1976	Pop	pe et al.					
	1B	4,146,029	03/1979	811	nwood, Jr.					
	1C 4.278,077 07/1981 Mi		Miz	Mizumoto						
	1D	4,425,117	01/1984	Hu	Hugemann et al.		· · · · · · · · · · · · · · · · · · ·			
	1E	4,439,197	03/1984	Ho	nda et al.					
	1F	4,507,115	03/1985	Kar	nbara et al.					
	1G	4,585,652	04/1986	Mill	ler et al.					
	1H	4,793,825	12/1988	Ber	njamin et al.		·············			
	11	4,844,076	07/1989	Les	ho et al.	\neg				
4	1J	5,217,449	06/1993	Yuc	da et al.					
M	J _{1K}	5,170,801	12/1992	Cas	sper et al.					
		DOCUMENT NUMBER	PUBLICATION DATE	·	PATENT DOCUM		Pages/Columns/Lines V evant Passages/Figures	Where Chec Transla s Appear attact	ation	
- PW	1L	EP 0734017A1	09/1996	Hewlet	t-Packard Co.					
M	1M	JP 5007573A	01/1993	Sony C	y Corp. At		tract Only		_	
	1N									
	10			<u> </u>			,		_	
	1P			<u> </u>					_	
		OTHER REFI	ERENCES (includ	ing Aut	hor, Title, Date, P	ertine	nt Pages, etc.)		_	
NN	10	Partial Search	Report mailed 16 .	July 200	02.	_			•	
RV	18	"Laser-induced crystallization of amorphous GeTe: A time-resolved study," Physical Review B, Condensed Matter, The American Physical Society, through the American Institute of Physics, pp. 1595-1604, Vol. 36, No. 3, Jul. 15, 1987								
MA	15	Structures, Ser	"Novel Polysilicon Comb Actuators for XY-Stages" V. P. Jaecklin, C. Linder, N. F. de Rooij, J. M. Moret, R. Bischof and F. Rudolf, Micro Electro Mechanical Systems, An Investigation of Micro Structures, Sensors, Actuators, Machines and Robots, pp. 147-149, IEEE Proceedings 1992, IEEE Catalog No. 92CH3093-2							
EXAM	INER	Killell	M		DATE CONSIDER	ED -				

FORM PTO-1449					ATTY, DOCKET NO.		APPLICATION NO	CONFIRMATION	NO.	
п	ST O	F PATENTS AND P	IBLICATIONS FOR		10002305-4					
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)					Daniel R. Marshall					
					FILING DATE GROUP					
					H rewith		Unkn.			
REFERE	NCE	DESIGNATION	U.S. PA	TEN	T DOCUMENTS					
			PUBLICATION DATE	NAME		F	Pages, Columns, Lines Where Relevant Passages or Figures Appear			
NN	2A	5,279,607	01/1994 Sc		Schentag et al. Schaefer					
	2B	2B 5,792,048 08/1998		Sch						
	2C 5,557,596 09/1996		Gib	Gibson et al.						
	2D	5,415,181	05/1995	Ho	Hogrefe et al.					
	2E	5,797,898	797,898 08/1998 S		Santini, Jr. et al. Gross et al.					
	2F	2G 5,984,875 11/1999 I		Gro			·			
	2G			Brune						
	2H			Gia	Giannos et al.					
	21	6,561,978	05/2003	Conn et al.						
	2J	6,510,380	01/2003	Cui	ratolo et al.					
EN	2K	6,416,474	07/2002	Per	nner et al.					
	DOCUMENT NUMBER 2L 2M		PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT		P	Pages/Columns/Lines Where Relevant Passages/Figures Appear		eck if slation ached	
	2N								—	
	20					-				
	2P									
*	1	OTHER REFI	ERENCES (including	g Au	thor, Title, Date, Pe	rtine	nt Pages, etc.)		
μN	20		umphrey, and E. R. V	ield E Veste	mission Cathodes With rberg, pp. 5248-5263	h Mol 3, Jou	lybdenum Cone irnal of Applied	s," C. A. Spindt, Physics, Dec.		
rv	2F	IEEE Transacti	"Silicon Field Emission Transistors and Diodes," Gary W. Jones, C. T. Sune, and Henry F. Gray, IEEE Transactions on Components, Hybrids, and Manufacturing Technology, 1051-1055, Dec. 1992, Vol. 15, No. 6.							
MN	25	"Bectron Bear Yacobi, pp. 69	"Bectron Beam-Induced Information Storage In Hydrogenated Amorphous Silicon Devices," B. G. Yacobi, pp. 695-697, Appl. Phys. Lett. 44 (7), April 1, 1984							
EXAMI	NER		+ 111		DATE CONSIDERE	Đ	 			
	1	no Val		7	7/7/6	5	.,			
Pev 05/03 (P	TO144				101		· 			

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EXAMINER INITIAL	DOCUMENT			Herewith		Unkn.		
INITIAL		U.S. P	ATEN	T DOCUMENTS				
1/1/1/2	NUMBER	PUBLICATION DATE		NAME		Pages, Columns, Unes Where Relevant Passages or Figures Appea		
	8A 6,428,469	08/2002	Iddan et al.				-	
3	B 6,240,312	05/2001	Alf	Alfano et al.				_
	C 427,243	05/1890	Na	ne not available				
4:	3D 5,681,260	10/1997	Uer	da et al.			•	
NO 3	BE 5,604,531	02/1997	ldd	an et al.				
3	BF							
[2	3G							
3	вн							_
3	ВІ							
5	3J							
- 1	вк			***************************************		***************************************		
	DOCUMENT NUMBER	PUBLICATION DATE		AME OF PATENTEE OR APPLICANT	Rel	Pages/Columns/Line evant Passages/Figu	ires Appear	Translatio attached
	вм							
3	BN							
3	30							
- 1	BP							
	OTHER REF	ERENCES (including	ng Au	thor, Title, Date, P	Pertine	ent Pages, etc.)		
nn	3Q "Silicon Micro Kaigham J. G	omechanics: Sensor abriel and William S.	s and A N. Tri	Actuators On A Chip immer, pp. 29-35, IE	o," Rog	ger T. Howe, Rich ectrum, July 199	ard S. Muller 0.	,
rr	3R "'Camera in a	Pill' Views Digestive	e Trac	t," The New York Ti	mes, S	Science Desk, Ma	y 30, 2000	
	38							
EXAMINE	L Kho	1		DATE CONSIDER	RED			